

Notice of References Cited	Application/Control No. 10/534,411		Applicant(s)/Patent Under Reexamination TSUYUMOTO ET AL.	
	Examiner ANISH DESAI		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Nagoya Fujiharu et al., "Microporous Film and Its Production", Machine Translation of JP 09-169867, 06/30/97.			
	V	Takehata Koji, "Polysulfone-Based Porous Film and Its Production", Machine Translation of JP 05-148383, 06/15/93			
	W	Tawara Shinji et al., "Porous Film For Prepreg and Prepreg For Circuit Board", Machine translation of JP 2002-037905, 02/06/02.			
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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